



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 9, 2026	
IGI Report Number	LG779667970
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE CUSHION MODIFIED BRILLIANT
Measurements	7.28 X 7.19 X 4.89 MM

GRADING RESULTS

Carat Weight	1.99 CARAT
Color Grade	D
Clarity Grade	VVS 2

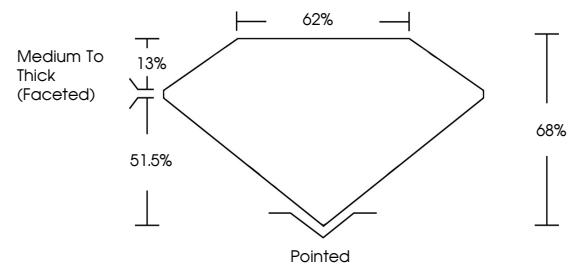
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG779667970

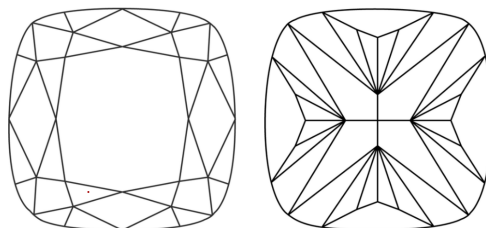
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG779667970
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

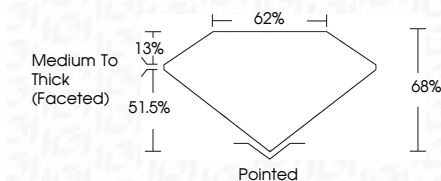
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

March 9, 2026
GJ Report No LEA
SQUARE CUSHION
.28 X 7.19 X 4.8
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Culet
Polish
Symmetry
Fluorescence
Annotations(s)

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.